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Application No.	10731,956	Prepared by	JS	Tracking Number	5977,92
Examiner-GAU	Nguyen-2811	Date	7/16/04	Week Date	7/5/04
		No. of queries	1	Per USPTO PW	

JACKET

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|----------------------|------------------------|--------------------|----------------|
| a. Serial No. | f. Foreign Priority | k. Print Claim(s) | p. PTO-1449 |
| b. Applicant(s) | g. Disclaimer | l. Print Fig. | q. PTOL-85b |
| c. Continuing Data | h. Microfiche Appendix | m. Searched Column | r. Abstract |
| d. PCT | i. Title | n. PTO-270/328 | s. Sheets/Figs |
| e. Domestic Priority | j. Claims Allowed | o. PTO-892 | t. Other |

SPECIFICATION

- a. Page Missing
- b. Text Continuity
- c. Holes through Data
- d. Other Missing Text
- e. Illegible Text
- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
- k. Other

MESSAGE

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CLAIMS

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- e. Index Disagrees
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- k. Other

Thank you
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RESPONSE

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<p>Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i></p>		Docket Number (Optional) <u>3924.3US (99-0034.03/US)</u>	Application Number <u>10173195L</u> <u>Net Yet Assigned</u>
		Applicant <u>Warren M. Farnworth</u>	
		Filing Date December 9, 2003	Group Art Unit Unknown
<p style="text-align: center;">OTHER DOCUMENTS</p> <p style="text-align: right;">(Including Author, Title, Date, Pertinent Pages, Etc.)</p>			
		U.S. Patent Application Publication No. 2002/0171177 A1 to Kritchman et al., dated November 21, 2002.	
		U.S. Patent Application Publication No. 2003/0151167 A1 to Kritchman et al., dated August 14, 2003.	
		MILLER et al., " Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22.	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16.	
		Webpage Objet Prototyping the Future, " Objet FullCure700 Series", 1 page.	
		Webpage Objet Prototyping the Future, Objet Technology, "How it Works", 2 pages.	
EXAMINER		DATE CONSIDERED	
<p>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</p>			

(2-92)

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Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>			Docket Number (Optional) 3924.3US (99-0034.03/US)		<i>101,131,958</i> Application Number Not Yet Assigned	
			Applicant Warren M. Farnworth			
			Filing Date December 9, 2003		Group Art Unit Unknown	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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	6,549,821	04/2003	Farnworth et al.			
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EXAMINER			DATE CONSIDERED			
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PTO/SB/08B(10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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Substitute for form 1449A/PTO				<i>Complete if Known</i>
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number
				10/731,956
				Filing Date
				December 9, 2003
				First Named Inventor
				Warren M. Farnworth
				Group Art Unit
				Unknown
				Examiner Name
				Unknown
(use as many sheets as necessary)				
Sheet	1	of	1	Attorney Docket Number
				3924 31US (99-0034.03/US)

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Signature		Date Considered	
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¹ Unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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